

Inventor: Paul A. Morgan

Title: Methods of Cleaning Surfaces of Copper-Containing Materials, and Methods  
of Forming Openings to Copper-Containing Substrates

Assignee: Micron Technology, Inc.

**INFORMATION DISCLOSURE STATEMENT**

**PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98**

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

The listed references were cited by, or submitted to, the Office in the parent, co-pending application of the above-identified application. The above-identified application is a continuation application of co-pending application Serial No. 09/579,333, filed May 25, 2000. Such prior disclosure is sufficient for the above-identified application as far as copies of the references are concerned. 37 C.F.R. § 1.98(d) and MPEP § 609(2).

Citation of these references is respectfully requested.

Respectfully submitted,

Dated:

October 10, 2003

By:

Jennifer J. Taylor  
Jennifer J. Taylor, Ph.D.  
Reg. No. 48,711

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2411	SERIAL NO. 09/579,333		
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Paul A. Morgan			
				FILING DATE May 25, 2000	GROUP 2812		
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	6,232,228 B1	05-2001	Kwag et al.			
	AB	6,143,658	11-2000	Donnelly, Jr. et al.			
	AC	5,017,267	05-1991	Cordani			
	AD	5,213,622	05-1993	Bohling et al.			
	AE	5,382,296	01-1995	Anttila			
	AF	5,863,344	01-1999	Nam			
	AG	6,136,767	10-2000	Hineman et al.			
	AH	5,633,121	05-1997	Namiki et al.			
	AI	4,938,257	07-1990	Morris			
	AJ	6,083,840	07-2000	Mravic et al.			
	AK	5,681,398	10-1997	Muraoka			
	AL	3,831,265	08-1974	Louzon et al.			
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
	AM						
	AN						
	AO						
	AP						
	AQ						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AR		Walker, P. et al., "HANDBOOK OF METAL ETCHANTS", CRC Press 1991, pp. 90-91.				
	AS						
	AT						
EXAMINER				DATE CONSIDERED			
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>							

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<b>U.S. PATENT DOCUMENTS</b>							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	6,361,712	03/02	Honda et al.			
	AB	6,391,794	05-02	Chen et al.			
	AC	6,319,543	11-01	Soutar et al.			
	AD	5,861,076	01/99	Adlam et al.			
	AE	6,541,391 B2	04-2003	Smith et al.			
	AF	6,589,882 B2	07-2003	Andreas et al.			
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
<b>FOREIGN PATENT DOCUMENTS</b>							
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